

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:

Osamu Nakamura

Application No. 10/807,472

Filed: March 24, 2004

For: PLASMA TREATMENT APPARATUS

) Confirmation No. 2927

)

) Examiner: Rakesh Kumar Dhingra

) Group Art Unit: 1763

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) Date: August 24, 2006

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**AMENDMENT AFTER FINAL REJECTION**

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Rakesh  
8/29/06

**MAIL STOP AF**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed April 24, 2006, please amend the above-captioned application as follows: